

## WEST Search History for Application 10599957

Creation Date: 2008062420:06

Query	DB	Op.	Plur.	Thes.	Date
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter ) and quantum	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter and quantum ) not optic\$6	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter ) and (mosfet or mos fet or set)	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter ) and ((mosfet or mos fet or set) near6 (transistor or source or gate or drain))	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with filter ) and ((mosfet or mos fet or set) with (sens\$4 or output) with (capacit\$4 or electrostatic\$4))	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with (resonator or beam or microbeam or microvibrator)) and ((mosfet or mos fet or set) with (sens\$4 or output) with (capacit\$4 or electrostatic\$4))	USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) with (resonator or beam or	USPT	ADJ	YES		06-24-2008

microbeam or microvibrator)) and ((sens\$4 electrode or output\$4 electrode) with ((source with gate) or (source with drain) or (gate with drain) or transistor))					
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) and ((sens\$4 electrode or output\$4 electrode) with ((source with gate) or (source with drain) or (gate with drain) or transistor))	USPT	ADJ	YES		06-24-2008
('4901586'   '5090254'   '5275055')![pn]	USPT, PGPB				06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine)) and (electrostatic\$4 with sens\$4)	PGPB, USPT	ADJ	YES		06-24-2008
((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine) with (beam or resonator or microbeam or microvibrator)) and (electrostatic\$4 with sens\$4)	PGPB, USPT	ADJ	YES		06-24-2008
((((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine) with (beam or resonator or microbeam or microvibrator)) and (electrostatic\$4 with sens\$4) ) and (transistor or mosfet or (source with drain) or (source with gate) or (gate with drain))	PGPB, USPT	ADJ	YES		06-24-2008
((((micro electromechanical or mems or micro electro mechanical or microelectromechanical or microelectro mechanical or micromechanical or micro mechanical or micromachine or micro machine) with (beam or resonator or microbeam or microvibrator)) and (electrostatic\$4 with sens\$4) ) and ((transistor or mosfet or (source with drain) or (source with gate) or (gate with drain)) with (capacit\$4 or electrostatic\$4))	PGPB, USPT	ADJ	YES		06-24-2008
('4918032'   '4997521')![pn]	USPT, PGPB				06-24-2008